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SERIAL NUMBER 10/800,377	FILING DATE 03/11/2004 RULE	CLASS 438	GROUP ART UNIT 2822	ATTORNEY DOCKET NO. NOVLP089/NVLS-002886/0028
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** CONTINUING DATA *****

This application is a CIP of 10/672,311 09/26/2003

W

** FOREIGN APPLICATIONS *****

W N/A

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 05/28/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY OR	SHEETS DRAWING 5	TOTAL CLAIMS 53	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	<i>[Signature]</i>	Initials			

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TITLE

Method and apparatus for UV exposure of low dielectric constant materials for porogen removal and improved mechanical properties

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other
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